



Elimination of Crumpled Leadframe Defect through Machine Sensor Enhancement

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Authors' contributions

This work was carried out in collaboration among the authors. All authors read, reviewed and approved the final manuscript.

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ABSTRACT

The paper focused on the improvement done in quad-flat no-leads (QFN) leadframe package assembly to address the quantity of rejection of crumpled leadframe during handling at wirebond process station. Overload sensor at the output magazine handler was found out to be defective, hence a new sensor was installed. With the improvement done, crumpled leadframe strip occurrence was ultimately eliminated.

Keywords: Assembly; crumpled leadframe; QFN; wirebonding.

1. INTRODUCTION

As the semiconductor technology continues on growing, the demand for new packages increases with efficiency, cost and reliability coinciding with the modern technological development. Quad-flat no-leads (QFN) leadframe technology is the most popular integrated circuit (IC) package in semiconductor

assembly industry. The fast pace growth on this package provides the need for every industry to come up with more innovative packaging solution to stay competitive in the semiconductor market. New technologies have a given manufacturability issues encountered during lot processing and one of the process mostly affected is the wirebonding process [1-4]. Wirebonding process is responsible in attaching the wires to provide

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electrical connections through combination of heat, pressure and thermosonic energy. This paper presents a solution and improvement done to process this type of assembly reject which is crumpled leadframe by replacing a new overload sensor at the output magazine handler. Overload sensor is a type of sensor that senses or detect an object and to push the leadframe on the output magazine. To guarantee its integrity during the processing, wirebond process is incorporated with a multiple of criteria such as, ball size, ball height, ball aspect ratio, wire-pull test, ball shear test, stitch-pull test, loop height, intermetallic coverage, contact angle, visual inspection and indexer planarity at output magazine. These wirebond criteria are performed after machine conversion or setup to ensure the product is reliable and robust. Fig. 1 shows the defect manifestation of crumpled leadframe at the output magazine.

2. PROBLEM IDENTIFICATION

A process macro map for QFN device in focus is illustrated in Fig. 2. Highlighted is the process mostly affected with the assembly issue of crumpled leadframe. Important to note that assembly manufacturing process flow differs with the technology and hence the product [5-7]. As mentioned earlier, with continuing technology development and breakthroughs, challenges in assembly manufacturing are unavoidable.

Crumpled leadframe is the top major assembly reject during handling ejection of leadframe onto

the output magazine at wirebond process station. The problem was identified to be caused by a defective overload sensor that senses the leadframe if it is already ejected. Parameter adjustment was done to address the crumpled leadframe strip, but it did not eliminate the reject occurrence. To isolate the main root cause, the overload sensor was replaced with a new one. Fig. 3 shows the defective overload sensor and crumpled leadframe

3. PROCESS IMPROVEMENT AND RESULTS

With the improved and enhanced process solution on QFN package handling during wirebonding process by replacing the overload sensor to a new one, crumpled leadframe issue was ultimately resolved. The leadframe used in this device is usually either a roughened or a standard pre-plated leadframe. Again, with the improvement done, no crumpled leadframe occurrence was observed during wirebonding process. Fig. 4 shows the actual newly replaced overload sensor.

Visual inspection during ejection of leadframe is not anymore needed, thus saving resources and time. Furthermore, faster delivery of units and business movement could be realized. A 100% improvement shared in Fig. 5 was achieved, with the crumpled leadframe occurrence successfully eliminated. Actual parts per million (ppm) is purposely not disclosed due to confidentiality.

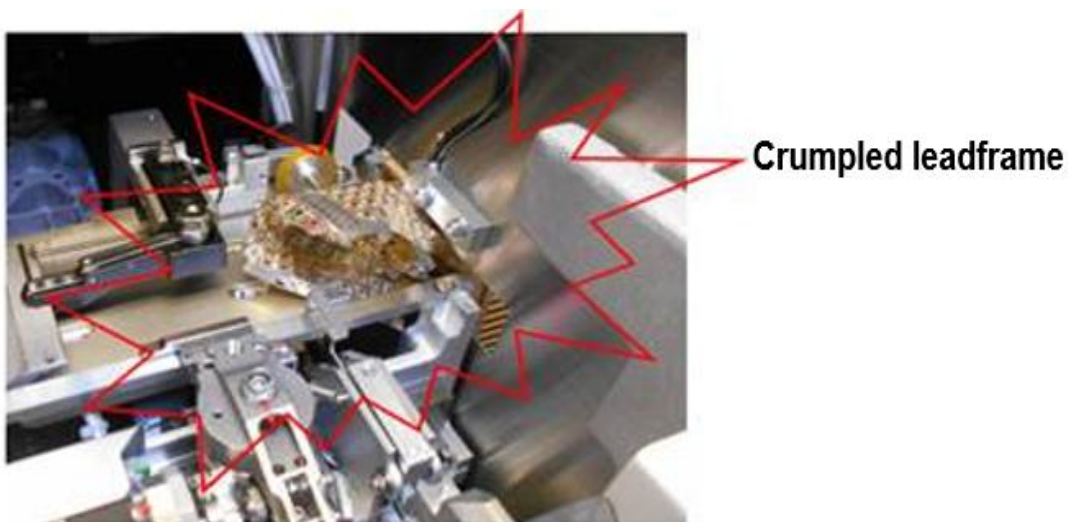


Fig. 1. Actual defect manifestation of crumpled leadframe strip

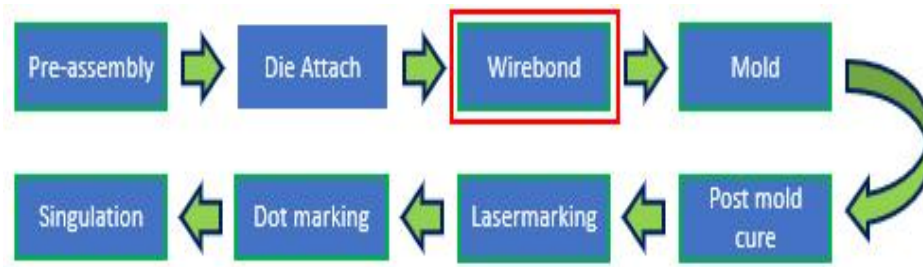


Fig. 2. QFN assembly process flow

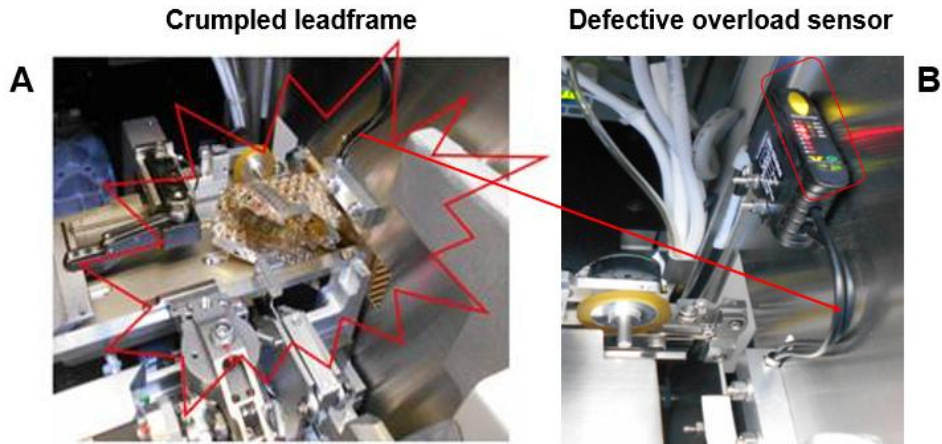


Fig. 3. Actual photo of the crumpled leadframe occurrence

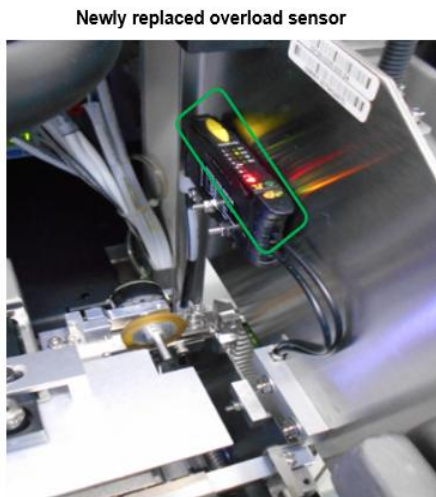


Fig. 4. New overload sensor

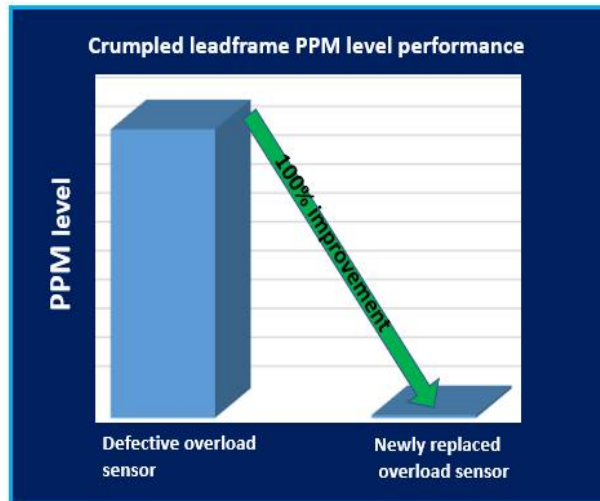


Fig. 5. Crumpled leadframe strip occurrence performance

4. CONCLUSION AND RECOMMENDATIONS

The paper discussed a process solution and improvement in addressing the crumpled

leadframe strip during leadframe handling or ejection at the output magazine handler at wirebond process. By replacing the overload sensor, crumpled leadframe occurrence on wirebond process was successfully mitigated.

For succeeding works, the machine configuration or setup could be used on packages with similar construction. Works and learnings discussed in [1,3,8-11] are helpful to improve the assembly processes focused on the front-of-line processes including wire bonding process.

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COMPETING INTERESTS

Authors have declared that no competing interests exist.

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